1. Record Nr. UNINA9910817296103321 Autore Stokes Debbie Titolo Principles and practice of variable pressure/environmental scanning electron microscopy (VP-ESEM) / / Debbie J. Stokes Chichester, U.K., : Wiley, 2008 Pubbl/distr/stampa **ISBN** 9786612343506 9781282343504 1282343505 9780470758731 0470758732 9780470758748 0470758740 Edizione [1st ed.] Descrizione fisica 1 online resource (235 p.) Collana RMS - Royal Microscopical Society Classificazione UH 6310 Disciplina 502.8/25 Soggetti Scanning electron microscopy Microscopy Lingua di pubblicazione Inglese **Formato** Materiale a stampa Monografia Livello bibliografico "Published in association with the Royal Microscopical Society." Note generali Nota di bibliografia Includes bibliographical references and index. Nota di contenuto Principles and Practice of Variable Pressure/Environmental Scanning Electron Microscopy (VP-ESEM); Contents; Preface; 1 A Brief Historical Overview; 1.1 Scanning Electron Microscopy; 1.1.1 The Beginnings; 1.1.2 The Need for Added Capabilities: 1.2 The Development of Imaging in a Gas Environment; 1.2.1 Overcoming the Limits of Conventional SEM; 1.2.2 Leaps and Bounds; 2 Principles of SEM; 2.1 Introduction; 2.1.1 Why Use An Electron Beam?; 2.1.2 The SEM Column; 2.1.3 Why Do We Need a Vacuum System?; 2.2 Electron Sources; 2.2.1

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## Sommario/riassunto

Offers a simple starting point to VPSEM, especially for new users, technicians and students containing clear, concise explanationsCrucially, the principles and applications outlined in this book are completely generic: i.e. applicable to all types of VPSEM, irrespective of manufacturer.Information presented will enable reader to turn principles into practicePublished in association with the Royal Microscopical Society (RMS) -www.rms.org.uk